

Electronic Acknowledgement Receipt

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Title of Invention:	Method of depositing an amorphous carbon film for etch hardmask application
First Named Inventor:	Yuxiang May Wang
Customer Number:	44257
Filer:	Steven Harry VerSteeg
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Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Amendment After Final	8244_RFOA_EF.pdf	196691	no	6

Warnings:	
Information:	
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